

Electronic Acknowledgement Receipt

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Document Number	Document Description	File Name	File Size(Bytes)/Message Digest	Multi Part /.zip	Pages (if appl.)		
1		2009-02-05-IDS.pdf	860479 c484bad3992167e79e1ea24ff386d95c5da bf224	yes	21		
Multipart Description/PDF files in .zip description							
Document Description		Start	End				
Information Disclosure Statement Letter		1	5				
Information Disclosure Statement (IDS) Filed (SB/08)		6	6				
NPL Documents		7	8				
Foreign Reference		9	14				
Foreign Reference		15	21				
Warnings:							
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